

BOX PCT
IN THE UNITED STATES DESIGNATED OFFICE
OF THE UNITED STATES PATENT AND TRADEMARK OFFICE
UNDER THE PATENT COOPERATION TREATY-CHAPTER II

5 **INFORMATION DISCLOSURE STATEMENT**

APPLICANT: Manfred WIEDEMER

ATTORNEY DOCKET NO. P04,0300

INTERNATIONAL APPLICATION NO: PCT/EP03/01497

INTERNATIONAL FILING DATE: February 14, 2003

10 INVENTION: **"PRINTING METHOD AND DEVICE USING
CONTROLLED RADIATION OUTLETS FOR CREATING
A STRUCTURE"**

15 **MAIL STOP PCT**
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

20 Sir:

In accordance with the provisions of 37 C.F.R. §1.56, Applicant respectfully requests that citation and examination of the following documents be made during the course of examination of the above-referenced PCT
25 application for United States Letters Patent.

EXPLANATION OF RELEVANCE

References AA, AB, AC, AD, AG, AM, AN, AO, AP, AQ2, AQ4, and AQ5 were cited for the reasons noted in Applicant's specification.

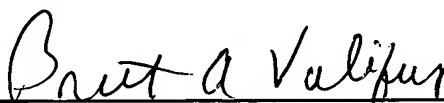
References AQ1, AQ3, and AH are cited for the reasons noted in the
30 International Search Report, a copy of which is enclosed. Reference AE is the U.S. equivalent of Reference AQ1 and Reference AF is the U.S. equivalent of AQ3.

References AL, AR, and AS are cited for the reasons noted in the German Patent Office Action of March 26, 2003, a copy of which is enclosed.

Copies of the above-cited references are enclosed together with Form 1449 for the Examiner's review.

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Submitted by,



(Reg. 27,841)

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Form PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION (use several sheets if necessary)					Docket No. P04,0300		Serial No. Notassigned	
					Applicant Martin WIEDEMER			
					Filing Date Herewith		Group Art Unit Notassigned	
U.S. PATENT DOCUMENTS								
Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If appropriate	
	AA	4,764,776	08/16/88	Mugrauer et al.				
	AB	5,067,404	11/26/91	Frunder et al.				
	AC	5,379,698	01/10/95	Nowak et al.				
	AD	6,016,750	01/25/00	Nüssel et al.				
	AE	6,180,213	01/30/01	Kuroki et al.				
	AF	6,204,875	03/20/01	De Loor et al.				
	AG	6,295,928	10/02/01	Heinzl et al.				
	AH	2001/0004265	21/06/01	Kurematsu				
	AI							
	AJ							
	AK							
	AK1							
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AL	38 21 268	12/28/89	Europe				
	AM	WO 97/36746	10/09/97	PCT				
	AN	0 746 470	10/22/97	Europe				
	AO	0 756 544	03/18/96	Europe				
	AP	WO 98/32608	07/30/98	PCT				
	AQ1	0 903 226	03/24/99	Europe				
	AQ2	WO 00/16988	03/30/00	PCT				
	AQ3	0 992 350	04/12/00	Europe				
	AQ4	WO 01/02170	01/11/01	PCT				
	AQ5	101 32 204	01/30/03	Germany				
	AQ6							
OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
	AR	Patent Abstracts of Japan 59008473 01/17/84						
	AS	Patent Abstracts of Japan 63015270 01/22/88						
	AT	Teschner: "Offsettechnik", 5. Auflage, Felbach, Fachschriften-Verlag 1983, p. 193-202 and S. 350						
	AU	From Cathode Rays to Digital Micromirrors: A History of Electronic Projection Display Technology Larry J. Hornbeck – July-September 1998						
	AV							
Examiner				Date Considered				
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								